



IGI GEMOLOGICAL REPORT

IGI LABORATORY GROWN DIAMOND GRADING REPORT

10/15/2020 IGI Report Number LG445044774

Shape and Cutting Style CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

Measurements 6.66 X 5.33 X 3.55 MM

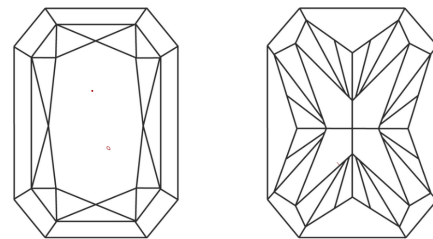
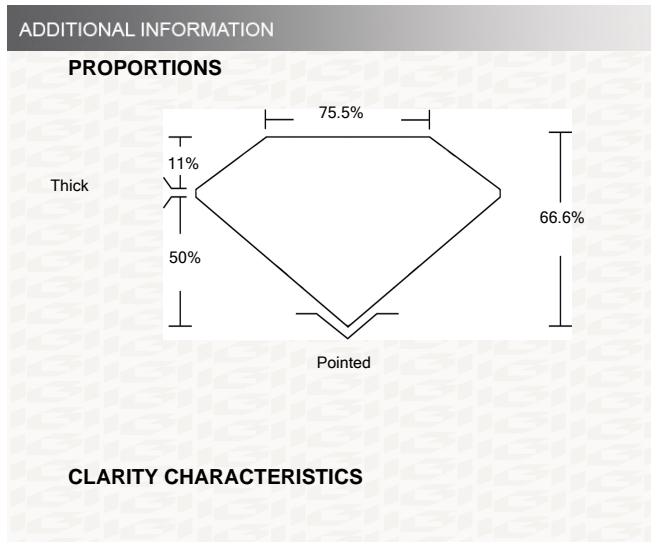
GRADING RESULTS

Carat Weight 1.11 CARAT Color Grade G Clarity Grade VS 1

ADDITIONAL GRADING INFORMATION

Polish EXCELLENT Symmetry VERY GOOD Fluorescence NONE Inscription(s) LABGROWN IGI LG445044774

Comments: This Laboratory grown diamond was created by chemical vapor deposition process (CVD) Type IIa



KEY TO SYMBOLS

Red symbols indicate internal characteristics. Green symbols indicate external characteristics.

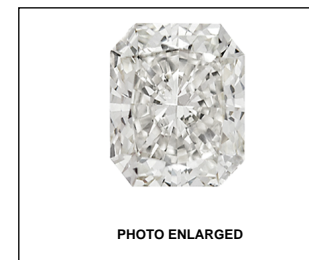
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GRADING SCALES

Table with 5 columns for Color Grading Scale (CL, NC, FT, VLT, LT) and 5 columns for Clarity (10x) Grading Scale (FL, IF, VVS, VS, SI, I).

The laboratory grown diamond described in this Report ("Report") has been graded, tested, analyzed, examined and/or inscribed by International Gemological Institute (IGI)...



LABGROWN IGI LG445044774

LASERSCRIBE SM



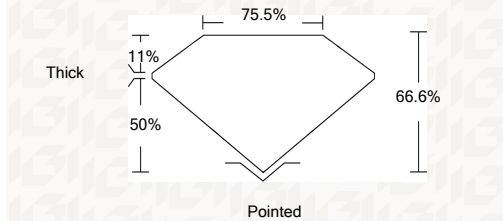
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